

ZEISS SPECTRUM

Specifications



Seeing beyond

System description

Type according to ISO 10360-1:2000	Bridge-type CMM with a moveable bridge							
Operating mode	Motorized / C	Motorized / CNC						
Sensor mounts	Fixed installati	Fixed installation						
Software	ZEISS CALYPSO							
			5/5/6	7/7/6 and 7/10/6	10/12/6 and 10/16/6			
Travel speed 4)	Motorized	Axes	0 to 70 mm/s	0 to 70 mm/s	0 to 70 mm/s			
	CNC	Vector	max. 346 mm/s	max. 346 mm/s	max. 346 mm/s			
Acceleration 5)		Vector	max. 866 mm/s ²	max. 866 mm/s ²	max. 866 mm/s ²			

ZEISS SPECTRUM Sensors and accuracy

The functionality of the device and its specifications are only achievable when using original accessories by ZEISS. The specified parameters are observed in the application of the internal test instructions for acceptance testing and in the use of the released standards in accordance with the ISO 10360 series.

ZEISS RDS-C5



Dynamic ZEISS RDS-C5 articulating unit for contact sensors.

Lateral swivel axis offers more benefits than articulating systems with front-to-back and lateral tilt axis; front-to-back and lateral tilt range of ±180°, large measuring range, rotation increments of 5°, CAA correction to automatically qualify all potential 5,184 angular positions.

ZEISS VAST XXT / ZEISS XDT







Measuring contact sensor direct or

attached to the ZEISS RDS-C5 articulating probe holder (only for VAST XXT). Stylus length with TL3 module = 30-150 mm; maximum sensor extension = 100 mm; maximum stylus weight = 15 g; minimum stylus tip diameter = 0.3 mm.

			5/5/6	7/7/6 and 7/10/6	10/12/6 and 10/16/6
Length measurement error 1) 2) 3) MPE complies with ISO 10360-2:2009	EO	in µm ZEISS XDT and ZEISS VAST XXT	1.9 + L/250	1.9 + L/250	2.1 + L/250
Repeatability range of E0 MPL complies with ISO 10360-2:2009	RO	in µm	1.9	1.9	2.1
Scanning tolerance MPE complies with ISO 10360-4:2000	THP	in μm	3.2	3.5	3.5
Required measuring time MPT	τ	in s	50	50	50
Form measurement error ⁴⁾ MPE for roundness complies with ISO 12181 (VDI/VDE 2617 sheet 2.2)	RONt (MZCI)	in μm	1.8	1.9	1.9
Single stylus form error MPE complies with ISO 10360-5:2010	PFTU	in µm	1.9	2.1	2.1

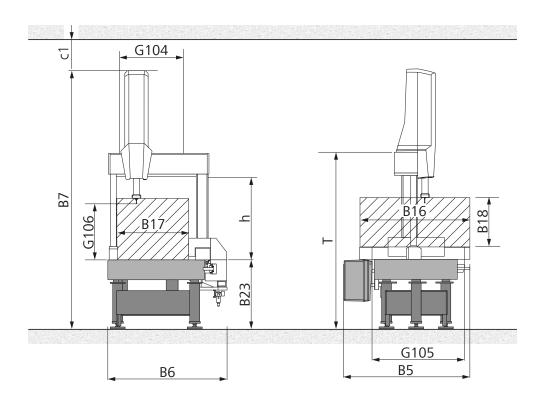
¹⁾ Acceptance test for ZEISS VAST XXT or ZEISS XDT with stylus length of 50 mm and sphere diameter of 3 mm.

Measuring length L in mm.

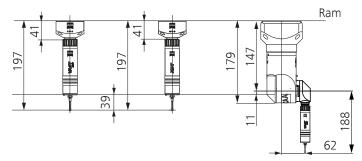
In compliance with the specified ambient conditions.
 Roundness in Scanning Mode on a 50 mm ring gauge for Vscan = 5 mm/s, filter 50 UPR.

	direct		RDS		
	II (50)				
	VAST XXT	XDT	VAST XXT R	DS-C5	
Multipoint	•	•	•		
Passive scanning			•		
Active scanning					
Max. stylus length 1)	150 mm	150 mm	150 mm		
Max. stylus weight 1)	15 g	15 g	15 g		

ZEISS	Dimens	ions in mm	1											Weight in kg	
SPECTRUM Sizes	Measuri	ing range		Overall	CMM dime	ensions		Working range (Max. workpiece size)			Table height	Assem- bly space	Trans- port height ²⁾	СММ	Max. workpiece
	X axis	Y axis	Z axis	Width	Length	Height	Width	Length	Height	Height	Height	Height	Height		
	G104	G105	G106	В6	B5	В7	B17	B16	B18	h	B23	c1	Т		
5/5/6	500	500	600	1219	1283	2640	715	830	620 1)	845	700	≥200	2050	910	400
7/7/6	700	700	600	1419	1483	2640	915	1030	620 1)	845	700	≥200	2050	1180	560
7/10/6	700	1000	600	1419	1783	2640	915	1335	620 1)	845	700	≥200	2050	1410	730
10/12/6	1000	1200	600	1720	1983	2640	1220	1535	620 1)	845	700	≥200	2050	2200	1150
10/16/6	1000	1600	600	1720	2383	2640	1220	1935	620 1)	845	700	≥200	2050	2700	1500



ZEISS VAST XXT direct ZEISS XDT direct ZEISS RDS-C5



Note: The given dimensions and weights are approximate values. Subject to change. Actual appearance of specific sizes may vary from illustration. Measuring range in Z (G106) and working area height (B18) may vary depending upon probe configuration. Dimensioning based on DIN 4000-167:2009.

¹⁾ Valid for ZEISS XDT direct or ZEISS VAST XXT only (to bottom edge of the ZEISS XDT sensor). Working range height (B18) is less for other sensor configurations.
2) Transport height of the secured machine group without pallet or Z tower. When transporting without foundation, deduct 600 mm from the transport height value.

Toc	hnical	l faati	Iros

- 40							
Reflected light length measuring system, photoelectric 0.2 µm resolution							
Туре	ZEISS C99m						
Cooling system:	Fan						
Multi-sensor Rack (MSR)	for storage of stylus systems						
40 - 60% (without condense	ation)						
18°C to 22° ²⁾							
Per day 1.5 K/d							
Per hour 1.0 K/h							
Spatial 1.0 K/m							
readiness							
	ation)						
+17°C to +35°C							
•							
Power consumption: max. 600VA Amount of heat generated: max. 2160 kJ/h							
Supply pressure min. 6 bar, max. 8 bar, pre-cleaned.							
Max. consumption: 120NI/min.							
Air quality complies with ISO 8573 Part 1: Class 4, i.e.							
Paragraph. 6.1: max. particle size 15 μm, max. dirt particle concentration 8 mg/m³							
Paragraph 6.2: max. compressed air dew point +3°C							
Paragraph 6.3: max. oil concentration of 5 mg/m ³ If the air supply does not comply with the above requirements, an additional air filter unit and,							
if necessary, a membrane dryer must be inserted in the compressed air line.							
ZEISS SPECTRUM complies with EC	machine directive 2006/42/EC, EMC directive 2014/30/EU and						
RoHS directive 2011/65/EU.							
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ZEISS products and packaging returned to us are disposed of in accordance							
with applicable legal provisions.							
ISO 9001:2015;							
VDA 6, Parts 4, 3. Version 2017							
ISO 14001:2015							
BS OHSAS 18001:2007							
	Type Cooling system: Multi-sensor Rack (MSR) 40 - 60% (without condense 18°C to 22° Per day 1.5 K/d Per hour 1.0 K/h Spatial 1.0 K/m readiness 40 - 60% (without condense +17°C to +35°C 1/N/PE 100-240 V 50-60 Hz, Power consumption: max. 600VA Amount of heat generated: max. 2 Supply pressure min. 6 bar, max. 8 Max. consumption: 120Nl/min. Air quality complies with ISO 8573 Paragraph 6.1: max. particle size Paragraph 6.2: max. compressed a Paragraph 6.3: max. oil concentratif the air supply does not comply vif necessary, a membrane dryer multiple supply for the supply does not comply with necessary, a membrane dryer multiple supply does not comply with necessary, a membrane dryer multiple supply does not comply with necessary, a membrane dryer multiple supply does not comply with necessary, a membrane dryer multiple supply does not comply with necessary, a membrane dryer multiple supply does not comply with necessary, a membrane dryer multiple supply						

Accredited

ISO / IEC 17025:2005

To ensure specified accuracies.
 At a measuring lab temperature that has remained constant for 48 hours.

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